



Patent Docket
LA-6762-102XX/09907997

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5/A
BAI-9-04

In re the Application of:

SYWE N. LEE

Serial No.: 09/433,677

Filed: November 4, 1999

For: INTERLACE OVERLAP PIXEL
DESIGN FOR HIGH SENSITIVITY
CMOS IMAGE SENSORS

Group Art Unit: 2612

Examiner: Moe, Aung Soe

RECEIVED

JAN 07 2004

Technology Center 2600

AMENDMENT AND RESPONSE

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby submits this amendment in response to the Office Action mailed

1/9/04
WJ July 2, 2003.

07/02/2004 13:01:00 60062005 300317 6043337

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